

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masashi Kawasaki et al.

Application No.: 10/588,283

Confirmation No.: 5019

Filed: July 23, 2007

Art Unit: 1792

For: METHOD OF MANUFACTURING THIN
FILM, METHOD OF MANUFACTURING p-
TYPE ZINC OXIDE THIN FILM AND
SEMICONDUCTOR DEVICE

Examiner: J. G. Horning

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated August 19, 2009, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.